

INFORMATION DISCLOSURE CITATION IN AN APPLICATION (Use several sheets if necessary)				Attorney Docket No.: 8038-1074		Application No.: 104583037 NEW NATIONAL PHASE	
				Applicant: Takashi ABE et al.			
				Filing Date: June 15, 2006		Group Art Unit:	
U.S. PATENT DOCUMENTS							
Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing date (if appropriate)	
FOREIGN PATENT DOCUMENTS							
Examiner Initial	Document Number	Date	Country	Class	Subclass	Translation Yes No	
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